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Our Case No. 10519/57

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Herner et al.

Serial No.: 09/928,975

Filing Date: August 13, 2001

For: LOW RESISTIVITY TITANIUM SILICIDE
ON HEAVILY DOPED
SEMICONDUCTOR

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Commissioner:

Applicant has enclosed copies of documents A1-A4 as listed on the attached Form PTO 1449. These documents are discussed in the opening paragraphs of this Application, and Applicant requests that they be reviewed and made of record.

Respectfully submitted,

WAW
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Registration No. 28,277
Attorney for Applicant

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